



Information

New Appointment of Representative Director

February 7, 2019

TOKYO - Nikon Corporation (Nikon) has announced that at the Board of Directors' Meeting held today decided to change Officers as of April 1, 2019 and to nominate new Representative Director who will be submitted for and subject to approval at the Annual Shareholders' Meeting and the subsequent Board of Directors' Meeting on June 27, 2019.

1. Reason for Changes

The reason for changes is to promote a new Medium-Term Management Plan which will start in the fiscal year ending March 31, 2020 under new management structure.

2. Change of Officers and Director

As of April 1, 2019

Name	New title	Former title
Kazuo Ushida	Representative Director Chairman of the Board	Representative Director President
Toshikazu Umatate	President	Senior Vice President

As of June 27, 2019

Name	New title	Former title
Toshikazu Umatate	Representative Director President & CEO	President

3. Brief Personal History and other information about the Newly-Appointed Representative Director

Name	Toshikazu Umatate	
Place of Birth	Fukuoka pref., Japan	
Date of Birth	March 1, 1956	
Education	The University of Tokyo, Master Course of Electric Engineering (Graduated in March, 1980)	
Professional Experience (as of February 7, 2019)	Apr. 1980	Joined Nippon Kogaku K. K. (renamed Nikon Corporation in 1988)
	Jun. 2005	Operating Officer General Manager of Development Headquarters of Precision Equipment Company
	Jun. 2012	Executive Officer Vice President of Precision Equipment Company & General Manager of Semiconductor Equipment Division, Precision Equipment Company

Jun. 2014	Senior Vice President General Manager of Semiconductor Lithography Business Unit
Apr. 2018	Senior Vice President General Manager of Semiconductor Lithography Business Unit, Officer in charge of Technology Strategy and Precision Components & Modules Business Unit
Number of the Company's shares held (as of January 31, 2019)	12,765 shares



Toshikazu Umatate